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PATENT
8007-1111

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Atsushi SAKURAI et al.

Conf. 1454

Application No. 10/583,942

Group 2812

Filed: June 22, 2006

Examiner Michael Lebentritt

Title: METAL COMPOUND, MATERIAL FOR
THIN FILM FORMATION, AND PROCESS
OF FORMING THIN FILM

SUPPLEMENTAL PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 16, 2007

Sir:

In response to the Notice of Non-Compliant Amendment
mailed April 25, 2007, please amend the above-identified
application as follows:

Amendments to the Claims are reflected in the listing
of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.